

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re U.S. Patent Application of** )  
 )  
**SUZUKI et al.** )  
 )  
**Application Number: To Be Assigned** )  
 )  
**Filed: Concurrently Herewith** )  
 )  
**For: AN IMAGE DISPLAY AND A DRIVING** )  
**METHOD OF THE SAME** )

**Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231**

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

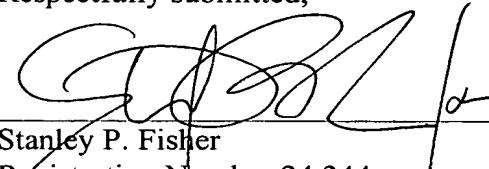
This Information Disclosure Statement is submitted with the initial application. Accordingly, no fee is due or payable at this time.

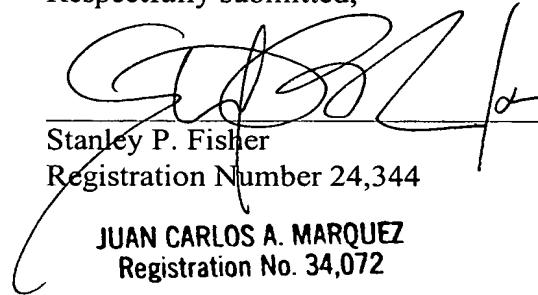
The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

10/031377  
JC13 Rec'd PCT/PTO 18 JAN 2002

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 08-1480.

Respectfully submitted,

  
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| Form PTO 1449<br><br>U.S. Department of Commerce<br>Patent and Trademark Office<br><br>Information Disclosure Statement by Applicant | ATTY. DOCKET NUMBER<br><br>NITT.0057     | MAIL NUMBER<br><br>Be Assigned |
|  | APPLICANT<br><br>SUZUKI et al.           |                                |
|  | FILING DATE<br><br>Concurrently Herewith | GROUP                          |

## U.S. Patent Documents

| EXAMINER<br>INITIAL |  | DOCUMENT<br>NUMBER | DATE | NAME | CLASS | SUBC<br>LASS | FILING DATE |
|---------------------|--|--------------------|------|------|-------|--------------|-------------|
|                     |  |                    |      |      |       |              |             |
|                     |  |                    |      |      |       |              |             |
|                     |  |                    |      |      |       |              |             |

## Foreign Patent Documents

**Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)**

|          |   |
|----------|---|
|          | Kuniyoshi Yokoo, Hiroshi Tanaka, Shinji Sato, Junichi Murota, and Shoichi Ono, "Emission Characteristics of Metal-Oxide-Semiconductor Electron tunneling Cathode", J. Vac. Sci. Technol. B 11(2), Mar/Apr 1993, pp. 429-432                         |
|          | Nobuyasu Negishi, Takashi Chuman, Shingo Iwasaki, Takamasa Yoshikawa, Hiroshi Ito and Kiyohide Ogasawara, "High Efficiency Electron-Emission in Pt/SiO <sub>x</sub> /Si/Al Structure", Jpn. J. Appl. Phys. Vol 36 (1997), 15 July 1997, pp. 939-941 |
|          | Nobuyoshi Koshida, Tsuyoshi Ozaki, Xia Sheng, and Hideki Koyama, "Cold Electron Emission from Electroluminescent Porous Silicon Diodes", Jpn. J. Appl. Phys. Vol 34 (1995), 1 June 1995, pp. 705-707.   |
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| EXAMINER | DATE CONSIDERED   |

*EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant*